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One step large-scale preparation of silicon-based efficient solar vapor generators†

D. W. Boukhvalov,^a B. Zhumabay,^{*b} P. Kusherova,^b B. Rakymetov,^b
K. B. Tynyshykbayev,^b A. S. Serikkanov^{bc} and N. V. Chuchvaga^b

In this work, the fabrication of the material for solar vapor generation using porous silicon treated by electrochemical etching, metal-assisted chemical etching, and electrochemical metal-assisted etching is reported. The proposed method does not require high-cost equipment and permits the production of centimeter-sized samples within minutes. Morphologies of the samples have been studied by scanning electron microscopy and X-ray diffraction spectroscopy, and the distribution of the impurities has been observed by dispersive X-ray analysis. First-principles modeling has been used to simulate the effect of nickel dopants on the electronic structure of the silicon matrix. Measurements of Raman spectra demonstrate a colossal increase in the signal intensity for all samples. The estimated vaporization performance of studied samples varies from 4.4 kg m⁻² h⁻¹ up to 5.2 kg m⁻² h⁻¹, more than four times larger than previously reported for silicon-based SVG systems prepared by more sophisticated techniques. The results of the measurements demonstrate the tiny influence of low-concentration doping on vaporization performance. On the contrary, higher porosity and more significant numbers of defects increase the vaporizing efficiency of studied samples.

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1. Introduction

Plasmon-enhanced solar vapor generation (SVG) has been extensively studied in the last decade as a technology for efficient water purification.¹ SVG is a natural photothermal phenomenon that induces a change in the liquid–vapor phase of water using solar energy. As an essential part of the water cycle, the Sun and Earth interact endlessly and provide purified water from seawater.² SVG is a natural photothermal phenomenon that induces a change in the liquid–vapor phase of water using solar energy. Solar-driven desalination is less susceptible to low-quality water sources and constituent concentration variations than membrane technology. However, highly polluted water feed may add complexity to the desalination process. However, such a natural SVG process is relatively inefficient (energy transfer efficiency <20%) because of the low solar energy harvesting capability and severe thermal losses. Plasmonic materials are promising candidates for enabling highly efficient SVG due to enhanced light–matter interactions and electromagnetic fields in a tiny volume, which are

beneficial for minimizing optical and thermal losses.³ Surface-enhanced Raman scattering is an essential criterion for evaluating SVG performance, as reported in recent works for gold nanoparticles,⁴ metal nitrides,⁵ silicon nanowires,⁶ and Au/Ni nanowires.⁷ Usually, materials for SVG consist of semi-conductive and metallic parts. The latter is primarily noble metal structures such as gold nanoparticles⁸ or hollow spheres.⁹ Organic systems with incorporated gold¹⁰ or silver¹¹ nanostructures demonstrate high SVG performance. The formation of the composites with some carbon systems is proposed for reducing the latent heat of vaporization.^{12,13} Usage of non-noble metals such as copper¹⁴ or aluminum¹⁵ was reported only in a few works. The cost and abundance of these metals limit the mass production of noble metals-based SVGs.

The fabrication of non-metallic SVG is not just a possibility but a vital necessity for advancing this field. In recent years, the SVG performance of carbon-based systems has been extensively studied for nanotubes^{16,17} and paper-based carbon-particle systems.¹⁸ However, the efficiency of synthesized carbon-based compounds is moderate (0.9–1.5 kg m⁻² h⁻¹),^{16–18} which is lower than what has been measured for silver-based systems reported in works mentioned above^{11,13} summarized in recent reviews (2–3 kg m⁻² h⁻¹).^{19,20} However, the surface enhancement of Raman spectra in silicon nanowires²¹ and nanopillars²² has been known for over a decade. Multiple works demonstrate the possibility of enhancing the Raman signal by manipulating the morphology of the surfaces of silicon nanowires,^{23,24} its arrays,²⁵ and leaf-like structures.²⁶ Another advantage of silicon-

^aCollege of Science, Institute of Materials Physics and Chemistry, Nanjing Forestry University, Nanjing 210037, P. R. China

^bInstitute of Physics and Technology, Satbayev University, Ibragimov Str. 11, Almaty 0500322, Kazakhstan. E-mail: b.zhumabay@sci.kz

^cNational Academy of Sciences of the Republic of Kazakhstan Under the President of the Republic of Kazakhstan, Shevchenko Str. 28, Almaty 050010, Kazakhstan

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based SVG is the stability in high-salinity brine reported for silicon-polymer composites.²⁵ Therefore, this research holds significant practical implications for developing efficient and stable SVG systems.

Despite the relatively low efficiency of Si-based SVG ($0.9\text{--}1.1\text{ kg m}^{-2}\text{ h}^{-1}$),^{25,26} the low cost, abundance, and potential for performance improvement through various surface treatments make this area of research compelling. The potential of silicon nanostructure for enhancement of Raman signal and reports of SVG-efficiency of metal nanoparticles encourage us to combine these two classes of materials. Recent works also demonstrate improvements in the plasmonic properties of silicon-based systems after incorporating metallic nanoparticles into silicon nanowires,¹⁷ coating the surface of porous silicon with gold and silver nanoparticles,^{27,28} embedding silver into silicon pyramids²⁹ and gold into flower-shaped nanostructures.³⁰ A multiplicity of methods for manufacturing incorporation of bimetallic,³¹ core-shell,³² and gold³³ nanoparticles into porous silicon demonstrates the high potential of the tuning physical properties of this material. This paper aims to inform and engage our audience by reiterating the potential of silicon-based systems for SVG and reporting the results of our study, which includes the one-step synthesis, characterization, and demonstration of outstanding SVG performance of silicon-based systems produced by three different methods with and without nickel content.

2. Experimental

Unilaterally polished wafers of monocrystalline silicon c-Si (100) produced by the Czochralski method (sz-Si), p-type boron-doped with an ohmic capacity of 10 ohm cm and thickness of 500 μm were used in the experiment. To form an ohmic contact, an aluminum layer (300 nm) was deposited on the polished surface of the silicon wafer by magnetron sputtering using Kurt J. Lesker LAB-18 Thin Film Deposition System (Source 2" magnetron with DC power supply, Target 2" $\times$ 0.250", Al 99.99% pure, pre-process pressure 7.5×10^{-7} torr, deposition pressure 5 mTorr, power 100 W, substrate rotation 10 rpm). The fabrication of the films was followed by annealing in an inert Ar medium at $T = 500\text{ }^{\circ}\text{C}$ for 30 min.

The morphology of the samples was studied by a Scanning Electron Microscope (SEM) Carl Zeiss Auriga Crossbeam 540 with an X-ray energy-dispersion analyzer (accelerating voltage 5.0 kV, thermionic emission cathode LaB₆), a Raman spectrometer, the Horiba LabRam Evolution, and the STA6000/8000

calorimeter of differential scanning calorimetry (DSC) and thermogravimetric analysis (TGA).

Porous silicon samples were synthesized by electrochemical etching (EC) without adding metal ions.³⁴ Two other methods were used to incorporate metal into the silicon matrix. First is pore etching by metal-assisted chemical etching (MACE) in hydrofluoride HF solution containing nickel nitrate $\text{Ni}(\text{NO}_3)_2$.³⁵ The second method combines electrochemical metal-assisted etching (EMACE) in a hydrogen fluoride solution containing nickel nitrate $\text{Ni}(\text{NO}_3)_2$ and hydrogen peroxide H_2O_2 as a strong oxidizer.^{36,37} Agilent Technologies LXI 300 V/11 A/3300 W stabilized direct current source was used as an external current source. Details of the synthesis are summarized in Table 1. The combinations of times and currents of etching are minimal values corresponding with the formation of porous structures. Lower current and shorter fabrication times correspond with the absence of porous structures. Fig. 1 shows photographic images of the sample prepared by the EMACE method. Samples prepared by other methods have the same size (the diameter is 1.6 cm, see Fig. 1b and c). The fabrication of the centimeter-sized samples does not require sophisticated equipment and expensive chemicals; the described method is suitable and reassuringly cost-effective for large-scale manufacturing of these materials.

To study water vaporization efficiency, the standard method reported in ref. 7 and 14 was used. The decay of their mass was measured using a ScoutPro 2000 g/0.1 g electronic balance on the surface of all discussed samples at room temperature. For

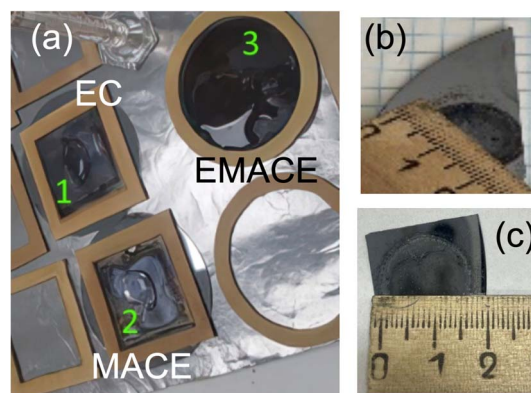


Fig. 1 A photographic image of the samples fabricated by different methods (a) and closer images for the samples prepared by EC (b) and EMACE (c) methods.

Table 1 Technical parameters of the synthesis procedure

Method	Electrolyte	Current j_{etch} , mA cm^{-2}	Etching time, s
EC	$\text{HF (4.5 mol l}^{-1}\text{): H}_2\text{O}_2 \text{ (0.8 mol l}^{-1}\text{)} = 1 : 1$	10	1800
MACE	$\text{HF (4.5 mol l}^{-1}\text{): H}_2\text{O}_2 \text{ (0.8 mol l}^{-1}\text{): Ni(NO}_3\text{)}_2 \text{ (0.02 mol l}^{-1}\text{)} = 1 : 1 : 1$	—	30
			60
			180
EMACE	$\text{HF (4.5 mol l}^{-1}\text{): H}_2\text{O}_2 \text{ (0.8 mol l}^{-1}\text{): Ni(NO}_3\text{)}_2 \text{ (0.02 mol l}^{-1}\text{)} = 1 : 1 : 1$	10	1800



this purpose, the water droplets of an almost round shape with a fixed diameter of 1.6 cm were placed on the surface. Then, the decrease in the mass of these droplets was continuously measured until their total evaporation of all water and returning of the weight of the samples to the values before water droplets formation.

3. Results and discussions

Fig. 2 shows SEM images of synthesized samples. Images of samples produced by EC and EMACE techniques depict the formation of a rod-like structure (Fig. 2a and d). On the contrary, samples produced by the MACE method have a porous structure. The shape of the pores does not depend on the fabrication time (see Fig. 2b and c). The calculated porosity of surface areas is 78%, 82%, 84%, and 91% for the samples fabricated by EC, MACE (60 and 180 s), and EMACE methods, respectively. Estimated specific area is about $600 \text{ m}^2 \text{ cm}^{-3}$. Note that using the EMACE method provides the formation of dendrites and similar rod-like structures.³⁸ These structures are comparable to those observed in silicon nanowires SVG.²¹

The energy dispersive X-ray analysis (EDS) demonstrates insignificant carbon and oxygen contamination in all considered samples (see Fig. 3a–c). This tiny amount of carbon and nitrogen impurities is natural for the silicon prepared by the Czochralski method.³⁹ The nucleation of carbon has also been observed in this type of silicon crystals.⁴⁰ Note that the most considerable carbon content (2.5 wt%) was observed for the samples fabricated by the MACE and EMACE methods; however, in the latter, the C:O ratio is vast (about 8:1). The formation of some carbon clusters on the silicon surface can be

proposed. The EDS map for the discussed material also demonstrates the tendency of carbon impurities segregation (see Fig. 3d). The more significant carbon content in the samples prepared by the EMACE method can be caused by the decomposition of carbon-containing volatile compounds on nickel centers, similar to those reported in the work by Y. Wang *et al.*⁴¹ On the contrary, the oxygen segregation was not observed. The combination of oxygen and carbon impurities in silicon-based structures can be associated with oxidized carbon-based structures⁴² or oxidation of defects on the silicon surface. The nickel content is very low in the samples (0.1 wt% and 0.2 wt% in samples prepared by MACE and EMACE methods, respectively). Nickel also demonstrates the lack of segregation (see Fig. 2d and S2†). Considering the larger mass of nickel atoms, nickel content in the samples is negligible. Note that the amount of nickel used in the etching is significantly smaller than that used for the fabrication (see Table 1). Hence, the nickel incorporated in the silicon surface can be discussed as residual and, therefore, the concentration of nickel in the samples defined only by fabrication method. Therefore, the phenomena discussed below can be mainly associated with the shape of porous silicon and carbon nanostructures in the samples prepared by the EMACE method.

The next step of our studies is the taking of XRD patterns. The absence of typical (001) and (002) peaks in XRD patterns of the samples prepared by EC and EMACE methods (Fig. 4a and c, respectively) can be attributed to the presence of a significant number of defects in these samples (see Fig. 2a and d). The smearing of these peaks is similar to those reported for porous silicon with many local defects.⁴³ However, the presence at about 64° (004) peaks demonstrates the survival of the long-

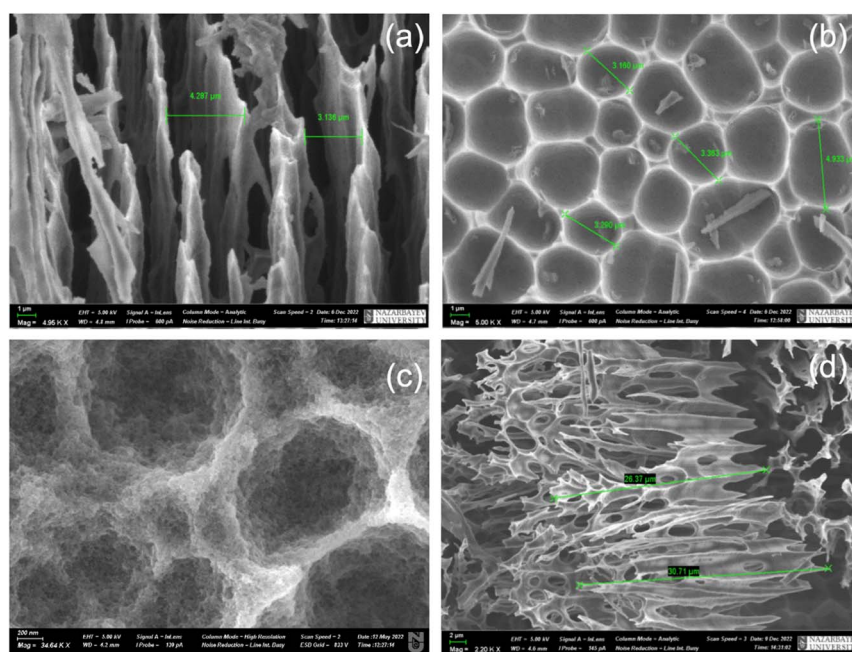
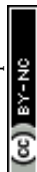


Fig. 2 SEM pictures of porous silicon prepared by EC method (a), Ni-decorated porous silicon prepared by MACE method with 60 (b) and 180 seconds etching, (c) and Ni-decorated porous silicon prepared by EMACE method (d). The size bars are one μm for panels (a) and (b), 200 nm for panel (c), and two μm for panel (d).



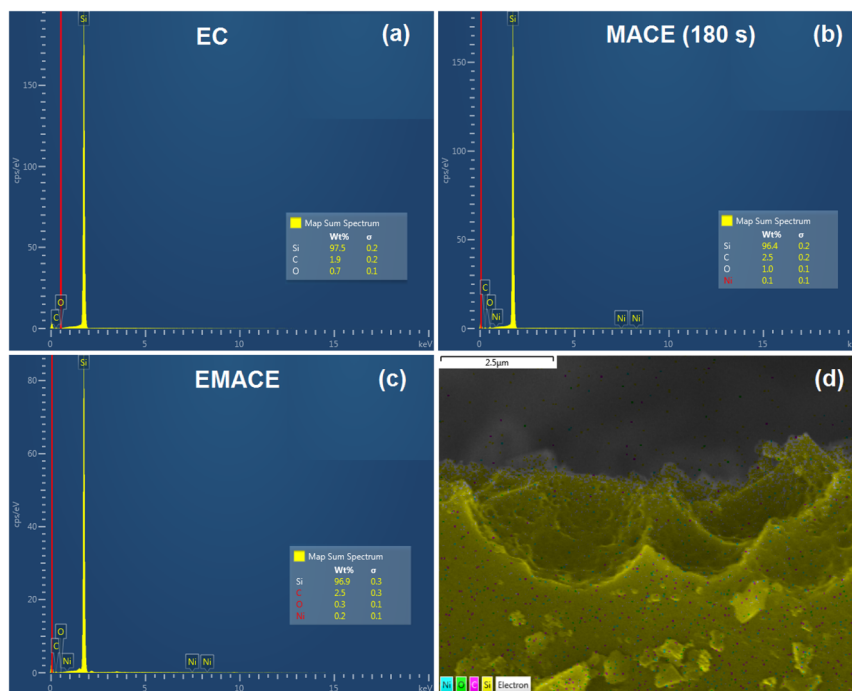


Fig. 3 EDS spectra of porous silicon prepared by EC method (a), Ni-decorated porous silicon prepared by MACE method with 180 seconds etching, (b) and Ni-decorated porous silicon prepared by EMACE method (c) and EDS map for the sample prepared by MACE (180 s) method (d).

distance order, even after significant changes and introducing a valuable amount of defects that correspond with the vanishing of (001) and (002) peaks. Similar XRD patterns were also observed for etched porous silicon.⁴⁴ On the contrary, lower degrees of morphological changes in the sample prepared by the MACE method (see Fig. 2b and c) correspond with XRD patterns identical to crystalline silicon. Similar patterns were also reported for porous silicon prepared by alkali chemical etching and ultra-sonication techniques.⁴⁵ Thus, different fabrication methods correspond with various degrees of local disorder without the amorphization of silicon.

The Raman spectra also demonstrate that samples with higher porosity have a higher intensity of the Raman peak at a high-frequency shift, as shown in Fig. 5a. The highest intensity of the Raman peak $I_v = 54\,000$ counts at a frequency

520.32 cm^{-1} is observed for the sample fabricated by EMACE method. For the samples prepared by MACE, the values of intensity and frequency are $33\,000$ counts and 519.66 cm^{-1} , respectively. The sample fabricated by the EC method demonstrates values of $17\,000$ counts at 519.11 cm^{-1} . The difference in peak position within 2 cm^{-1} is typical for the porous silicon prepared by different etching modes (see, for example, work by R. Venkatesan *et al.*,⁴⁶). The Raman peak intensity for c-Si is $2,000$, and the corresponding frequency is 519.11 cm^{-1} . The Raman spectra of c-Si and studied porous silicon samples have a characteristic resonance peak due to electron-phonon scattering, the intensity and frequency of which depend on the concentration of scattering centers and, consequently, on the conditions for forming pores. The high-frequency shift and decrease in the full width at half maximum of the main peak,

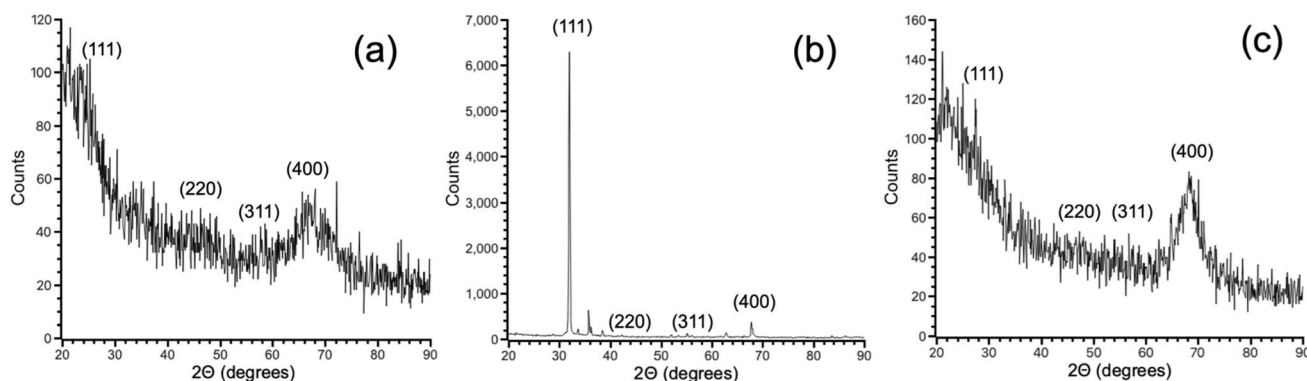


Fig. 4 XRD patterns of the samples prepared by EC (a), MACE (180 s) (b), and EMACE (c) methods.

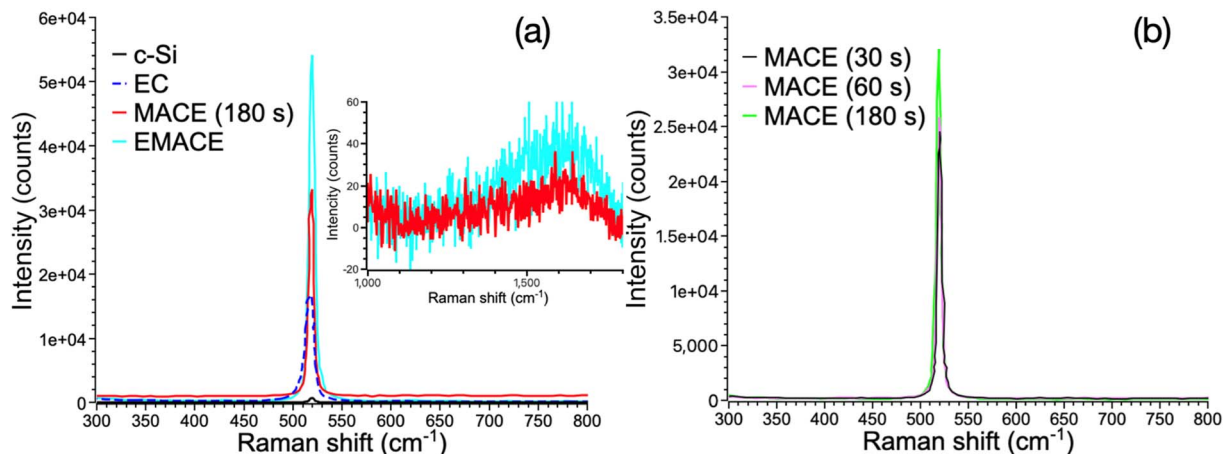


Fig. 5 Raman spectra for crystalline (c-Si) and porous silicon with and without nickel prepared by different methods (a) and for Ni-decorated porous silicon prepared by MACE method with varying times of etching (b). Raman signals from carbon bonds-related areas for the samples prepared by MACE (180 s) and EMACE methods are depicted in the inset in panel (a).

FWHM, due to the increase in peak intensity, is most significant in the sample fabricated by the EMACE method. This phenomenon can be attributed to the rise in the number of Raman scattering centers in nanocrystalline silicon, as described before.⁴⁷ Varying of the etching time in the MACE method also corresponds with increasing porosity of the samples and therefore leads to the enhancement of the intensity of the Raman peak from 20 000 for samples prepared in 30 seconds up to 30 000 for the samples etched 180 seconds (see Fig. 5b). Since the samples fabricated by EC and EMACE methods demonstrate a similar porosity level (Fig. 2a and d), the enhancement of the Raman signal cannot be solely attributed to the increase of the porosity. Even a tiny amount of metal content can be crucial for increasing the intensity of the Raman peak. Note that Raman spectra for all samples demonstrate the absence of nanosized Ni-related features at 550 cm^{-1} .⁴⁸

A possible additional source of enhancement of the Raman peak is the doping of substitutional and interstitial single nickel atoms incorporated into the silicon matrix. Since a high rate of nickel absorption into the silicon has been reported in multiple

experiments (see, for example ref. 48 and 49) the effect of the Ni-doping on the local electronic structure was studied. The modeling of substitutional (Ni_{Si}) and interstitial (Ni_{i}) defects has been carried out. The simulation details are the same as in our recent work.⁵⁰ As shown in Fig. 6a and b. The electronic structure of substitutional nickel impurity has the same peak at the Fermi level as silver (see Fig. 6c). Since the silver nanostructures demonstrate enhancement of the Raman peak and SVG performance, an increase in the intensity of the Raman peak in the sample prepared by EMACE method with silver-like changes in local electronic structures in Ni-doped silicon matrix can be associated.

To check the possibility of the carbon nucleation reported for cz-Si^{51} and the formation of some ordered carbon structures, the Raman spectra in the range between 1000 and 2000 cm^{-1} in the sample with the most significant carbon content (EMACE) have been taken. Results of measurements demonstrate the presence of some carbon-carbon bonds in the spectra (see inset in Fig. 5a) without typical for various layered carbon structures D and G peaks.⁵² Based on the tiny magnitude of the Raman

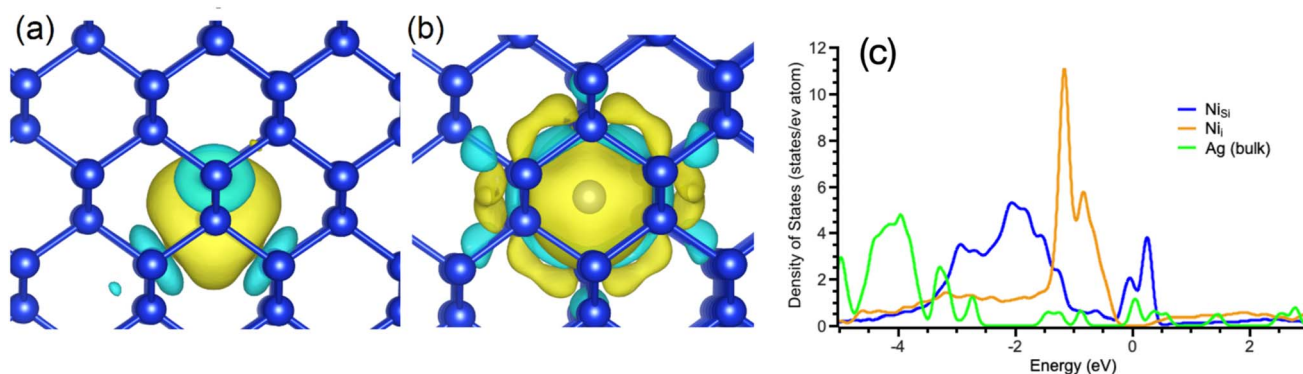


Fig. 6 The changes of the charge densities after incorporation of substitutional (a) and interstitial (b) nickel impurity. The yellow "clouds" correspond with an increase in the charge densities, and the cyan "clouds" correspond with a decrease in the charge densities. Panel (c) depicts partial densities of states for metallic silver, substitutional, and interstitial nickel impurities in a silicon matrix.



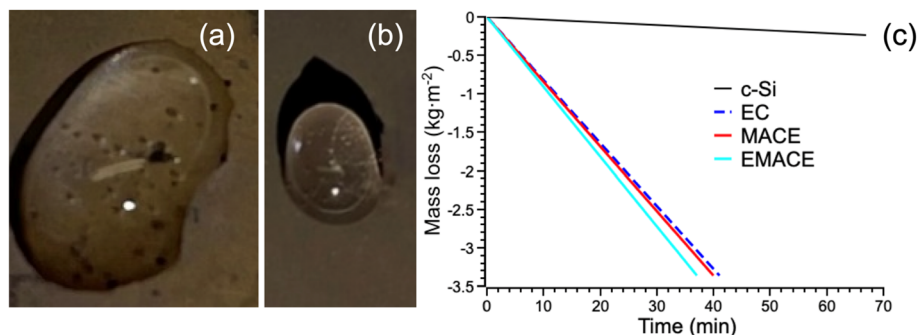


Fig. 7 Photographic images of the bubbles formed in water on the surface of samples prepared by EMACE (a) and MACE (b) methods. Panel (c) shows mass variation over time at room temperature over silicon-based substrates fabricated by various methods.

signal from these carbon structures and the absence of peaks corresponding with ordered carbon structure, these carbon structures provide no effects on enhancing the Raman signal.

The next step of our studies is to check the samples' vaporization performance. Shapes of the water droplets depict a hydrophilic character of the surface area for all studied samples (see Fig. S2†). Fig. 7a and b shows the formation of bubbles on the surface of freshly prepared samples at room temperature. The vaporizing performance for the samples fabricated by EC, MACE, and EMACE methods is about 4.4, 4.6, and 5.2 kg m⁻² h⁻¹, respectively (see Fig. 7c). Note that the latter value is an approach to the maximal reported performance of SVG devices (5.7 kg m⁻² h⁻¹).¹⁵ Since the intensity of the Raman peak of the sample fabricated by the MACE method is almost two times larger than for the samples prepared by the EC method (33 000 counts vs. 17 000 counts), the nearly identical vaporization performance of these samples demonstrates the influence of other factors on this property. The different shapes of the surfaces of these samples (see Fig. 2a and d) and different degrees of structural disorder (see Fig. 4a and c). The samples prepared by the EMACE method demonstrate higher porosity and a more significant number of defects than those prepared by the MACE method (see Fig. 2). To evaluate the wettability of the samples, water droplets were formed on the surfaces and removed after one minute. After this, the samples were weighted. The measured weight of the water remaining in the samples after brief surface wetting is 16.5, 5.9, and 17.3 g m⁻² for the samples prepared by EC, MACE (180 s), and EMACE methods, respectively. Thus, the discussed differences could be associated with different wetting patterns, which are also essential for SVG performance.⁵³

4. Conclusions

This work presented the fabrication of centimeter-size porous silicon with and without Ni-doping using a one-step process. Microscopy demonstrates various morphologies of the samples prepared by different methods. The metal-assisted chemical etching (MACE) samples exhibit a lower porosity level. On the contrary, the samples prepared by electrochemical etching (EC) and electrochemical metal-assisted etching (EMACE) have rod-like morphology. XRD measurements also demonstrate

differences between these two types of morphology: EC samples exhibit a high level of crystallinity, in contrast to samples prepared by EC and EMACE methods. Later, it reflects the lack of short-distance orders. Raman spectra show dramatic enhancement in the magnitude of the signal. EMACE sample demonstrates the most significant increase in the Raman signal intensity. This effect can be partially associated with silver-like features in the electronic structures in Ni-doped areas. Drops of water were placed on the surface of all studied samples to evaluate solar vapor generation performance. The visible naked-eye vapor bubbles formed inside these water drops were observed in the MACE and EMACE samples prepared. The estimated vaporization performance of studied samples varies from 4.4 kg m⁻² h⁻¹ for EC samples up to 5.2 kg m⁻² h⁻¹ for EMACE samples. The numbers above are reported for the various systems prepared by more sophisticated techniques and more than four times more significant than previously reported for silicon-based SVGs prepared in smaller quantities using more sophisticated techniques (0.9–1.1 kg m⁻² h⁻¹).^{25,26} Thus, simple one-step methods for large-scale manufacturing of centimeter-size from cz-Si are prospective for developing efficient solar vapor generators for industrial manufacturing. Further developments in this direction required studies of the effects of aging, harsh environments, and water salinity on the stability and performance of tissue kind of SVG.

Data availability

Data for this article, including results of XRD and Raman measurements, are available at Science Data Bank at <https://doi.org/10.57760/sciencedb.17873>.

Conflicts of interest

There are no conflicts to declare.

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